

MEI LLC Announces new 'Revolution' Automated Multi-step Wet Processing System

Albany, OR. June 30, 2008 – MEI LLC announced the introduction of its newest in a line of precision batch wet processing systems- the “Revolution” Automated Multi-step Wet Processing System today at Semicon West.

MEI’s “Revolution” Automated Multi-step Wet Processing system combines ease of process control with a rotary robot design and precision engineering to create a powerful, flexible tool with a minimal fab footprint. The easily managed IDX automation software provides outstanding control and programmability, and the new rotary design and robotics handle carriers of 300mm wafers through multiple process steps in a very small footprint.

The “Revolution” wet process system can be built of Halar, Stainless, PVDF, or conventional materials and is SEMI S2 and FM4910 compliant. Configurability, up-time, yield and throughput are hallmarks of MEI’s wet process systems. The “Revolution” is an addition to MEI’s very successful lines of Automated, Semi-automated and manual batch wet process systems.

About MEI LLC

MEI is a diversified manufacturing and service company serving the semiconductor and high technology industries. The company’s specialties include wet process systems and services; automated chemical delivery systems, robotics automation software; factory relocations, process tool rigging and crating services; clean room safety, ergonomic and support equipment; as well as a variety of manufacturing services, including machine, metal and plastic fabrication and powder coating. MEI was founded in 1990 and currently employs more than 100 people. For more information about MEI, visit www.meillc.com.